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June 23, 2003

MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re

Application of Kenji TSUKADA

LIQUID EJECTING APPARATUS AND METHOD FOR CLEANING THE

SAME

Assignee: SEIKO EPSON CORPORATION

Our Ref. Q76217

Dear Sir:

Attached hereto is the application identified above comprising forty-four (44) sheets of the specification, including the claims and abstract, and ten (10) sheets of drawings. The executed Declaration and Power of Attorney, Requisite U.S. Government Filing Fee, and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:



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Priority/Benefit is claimed from:

<u>Country</u> JAPAN	Application No 2002-181654	Filing Date June 21, 2002
JAPAN	2003-172520	June 17, 2003

The priority documents will be filed at a later date.

Since the anniversary of the earliest priority date fell on a Saturday, the filing of this application on Monday, June 23, 2003 is sufficient to obtain the benefit of priority of the earliest priority documents.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

Darryl Mexic

Registration No. 23,063

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